Jacqueline J Garner

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p. 1

From:

Jacqueline J. Garner

Texas Instruments Incorporated

Phone: 214-532-9348

JAN 2 8 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Lu et al.

Art Unit:

2826

Serial No.:

10/722,013 11/25/2003 Examiner:

Erdem, F. TI-35669

Filing Date:

Docket No.: Conf. No.:

6979

Customer No.: 23494

Title: A CAPACITOR FORMED ON A RECRYSTALLIZED POLYSILICON LAYER AND A METHOD OF MANUFACTURE THEREFOR

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on the date shown below:

Samer, Reg. No. 36,144 Jacqueline .

January 28, 2005

Date

FACSIMILE COVER SHEET

X FACSIMILE COVER SHEET NEW APPLICATION DECLARATION (# Pages) ASSIGNMENT (# Pages) FORMAL DRAWINGS INFORMAL DRAWINGS CONTINUATION APP'N (# Pages) DIVISIONAL APP'N		X AMENDMENT (8 Pages) X EOT 3mth (2 Pages) NOTICE OF APPEAL (# Pages) APPEAL (# Pages) ISSUE FEE (# Pages) REPLY BRIEF (IN TRIPLICATE) (# Pages) X Claim Fee (2 pages)			
NAME OF INVENTOR(S): LU TITLE OF INVENTION: A Capacitor		Serial No.: 10/722,013 Filing Date: 11/25/2003 Conf. No.: 6979			
TIFILE NO.: TI-35669 FAXED: 1/28/2005 DUE: 10/28/2004 ATTY/SECY: JJG	DEPOSIT ACCT. NO.: 20-0668				

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> Texas Instruments Incorporated PO Box 655474, M/S 3999 Dallas, TX 75074

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Title: A CAPACITOR FORMED ON A RECRYSTALLIZED POLYSILICON LAYER AND A METHOD OF MANUFACTURE THEREFOR

Amendment Fee

Assistant Commissioner of Patents

P. O. Box 1450

Alexandria, VA 22313-1450

January 28, 2005

Dear Sir:

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on the date

J. Garner, Reg. No. 36,144

January 28, 2005 Date

p.10

Transmitted herewith is an amendment in the above-identified Application. The Fee has been calculated as shown below.

CLAIMS AS AMENDED								
	Claims remaining after amendment		Highest Number Previously Paid for	Present Extra	Rate	Additional Fee		
TOTAL	21	Minus	20	= 1	× \$50	\$ 50.00		
Independent Claims	5	Minus	3	= 2	x \$200	\$ 400.00		
Total Additional Fee for this Amendment						\$ 450.00		

Charge the total additional fee, and any further fees, or credit any overpayment to Deposit Account No. 20-0668.

Texas Instruments Incorporated P. O. Box 655474, MS 3999 Dallas, Texas 75265

Jacqueline J. Gamer

Respectfully Submitted,

Reg. No. 36,144